

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of
Mills

Group Art Unit: 1754

Application No. 09/501,622

Examiner: Langel

Filed: February 9, 2000

For: DOPED SEMICONDUCTOR AND METHOD OF MAKING THE DOPED
SEMICONDUCTOR

*

*

*

*

*

March 25, 2002

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

Attached are PTO/SB/O8A and B forms listing the enclosed documents. Copies of the enclosed documents are attached to this Information Disclosure Statement and/or to the Attachments to the Response filed herewith.

Should a first action on the merits have been issued on the same day or before this Information Disclosure Statement is filed, please accept this Information Disclosure Statement under Rule 97(c) and charge the requisite Rule 17(p) fee to our Deposit Account No. 50-0687 under Order No. 27462/62-226 for which purposes this paper is submitted in duplicate.

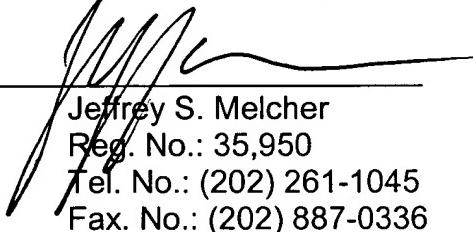
This information disclosure statement is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice that effect is earnestly solicited, along with additional time under

09/501,622
Mills
Page 2

Rule 97(f), to enable Applicant to comply fully. Consideration of the foregoing and enclosures plus the return of a copy of the herewith PTO/SB/08A and B forms with the Examiner's initials in the left column per MPEP 609 along with an early action on the merits of this application are earnestly solicited.

Respectfully submitted,

Manelli Denison & Selter PLLC

By 

Jeffrey S. Melcher
Reg. No.: 35,950
Tel. No.: (202) 261-1045
Fax. No.: (202) 887-0336

Customer No. 20736